



PATENT APPLICATION
Docket No. 8371-129

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Apostolos Voutsas and Yukihiro Nakata

Serial No. 09/945,063

Examiner: G. R. Fourson III

Confirmation No. 3014

Filed: August 31, 2001

Group Art Unit: 2823

For: METHOD OF FORMING MULTI-LAYERS FOR A THIN FILM TRANSISTOR
(TFT) AND THE DEVICE FORMED THEREBY

MAIL STOP FEE AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, dated February 28, 2003, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.